PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
CHISUNG BAE	10/30/2015
HAIBING REN	10/30/2015
YONGNAN JI	10/30/2015
XUETAO FENG	10/30/2015
BIAO WANG	10/30/2015
SANGJOON KIM	10/30/2015

RECEIVING PARTY DATA

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PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14983112

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DATE SIGNED:	12/29/2015

Total Attachments: 3

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PATENT REEL: 037378 FRAME: 0743

Attorney Docket No.: 012052.1275

COMBINED DECLARATION AND ASSIGNMENT UNDER 37 CFR 1.63(e)

DECLARATION

As a below-named inventor, I hereby decla	re that this declarat	ion is directed to the application attached
hereto, or to United States Application Nun	nber or PCT Intern	ational Application Number
filed on		(if applicable), entitled:
METHOD AND APPARATUS FOR	AUTHENTICATI	ING USER BASED ON BIOSIGNAL
The above-identified application was made	or authorized to be	e made by me.
I believe I am the original inventor or an oridentified application.	iginal joint invento	or of a claimed invention in the above-
I hereby acknowledge that any willful false USC 1001 by fine or imprisonment of not r		•
I have reviewed and understand the content	ts of the above-ider	tified application, including the claims.
I am aware of the duty to disclose to the Ur known to me to be material to patentability applications, material information that beca and the national or PCT international filing	as defined in 37 Came available between	FR 1.56, including for continuation-in-part een the filing date of the prior application
	ASSIGNMENT	
For valuable consideration, I, as a below-na	amed assignor, here	eby assign to:
Samsung Electronics Co., Ltd. 129, Samsung-ro, Yeongtong-gu Suwon-si, Gyeonggi-do, 443-742 Republic of Korea		
and its successors and assigns (collectively	hereinafter called '	'the Assignee"), the entire right, title, and
interest throughout the world in the inventi-	ons and improveme	ents that are the subject of the application
identified in the above declaration, which is	s United States App	olication Number or PCT International
Application Number 14/983,112	filed on _	December 29, 2015 .
I authorize and request the attorneys appoir	nted in the above-id	lentified application to hereafter complete

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this Assignment by inserting above the application number and the filing date of the above-identified

Attorney Docket No.: 012052.1275

application when known, and to correct any typographical errors that may be discovered in this Assignment.

This Assignment includes the above-identified application, any and all United States and foreign patents, utility models, and design registrations granted for any of the inventions and improvements that are the subject of the above-identified application, and the right to claim priority based on the filing date of the above-identified application under the International Convention for the Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all other treaties of like purposes; and I authorize the Assignee to apply in all countries in my name or in its own name for patents, utility models, design registrations, like rights of exclusion, and inventors' certificates for any of the inventions and improvements that are the subject of the above-identified application; and I agree for myself and my heirs, legal representatives, and assigns without further compensation to perform such lawful acts and to sign such further applications, Assignments, preliminary statements, and other lawful documents as the Assignee may reasonably request to effectuate fully this Assignment.

In witness whereof, I, as a below-named inventor and assignor, intending to be legally bound, have hereunto affixed my signature on the date indicated below next to my signature.

Inventor's Legal Name	Chisung BAE		
Inventor's Signature	10m2 (49-	Date	October 30, 2015
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Inventor's Legal Name	Biao WANG		
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